



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG783665149
Report verification at igi.org

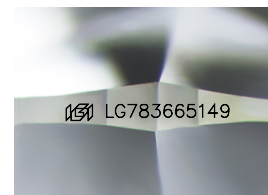
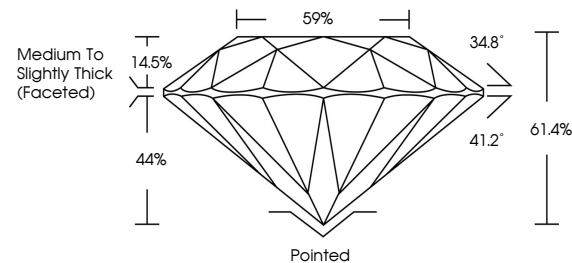
March 24, 2026	
IGI Report Number	LG783665149
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	10.93 - 11.01 X 6.75 MM
GRADING RESULTS	
Carat Weight	5.02 CARATS
Color Grade	E
Clarity Grade	VS 1
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG783665149

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

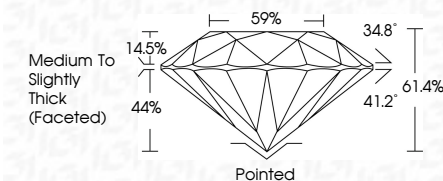
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

March 24, 2026	Carat Weight	5.02 CARATS
GI Report No. LG783665149	Color Grade	E
ROUND BRILLIANT	Clarity Grade	VS 1
	Cut Grade	IDEAL
	Depth	61.4%
	Table	89%
	Grille	Medium to Slightly Thick Faceted
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Inscriptions(s)	lgf LG783665149

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition process.

Type IIc